

Supporting information

**High throughput processing of dinaphtho[2,3-b:2',3'-f]thieno[3,2-b]thiophene (DNTT)
organic semiconductors**

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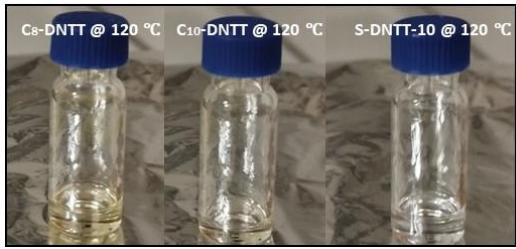
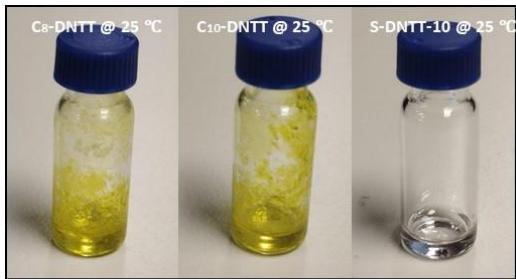


Figure S1. Solutions prepared with the different DNTT derivatives in PhCl (2% wt.) at 25 and 120 °C.

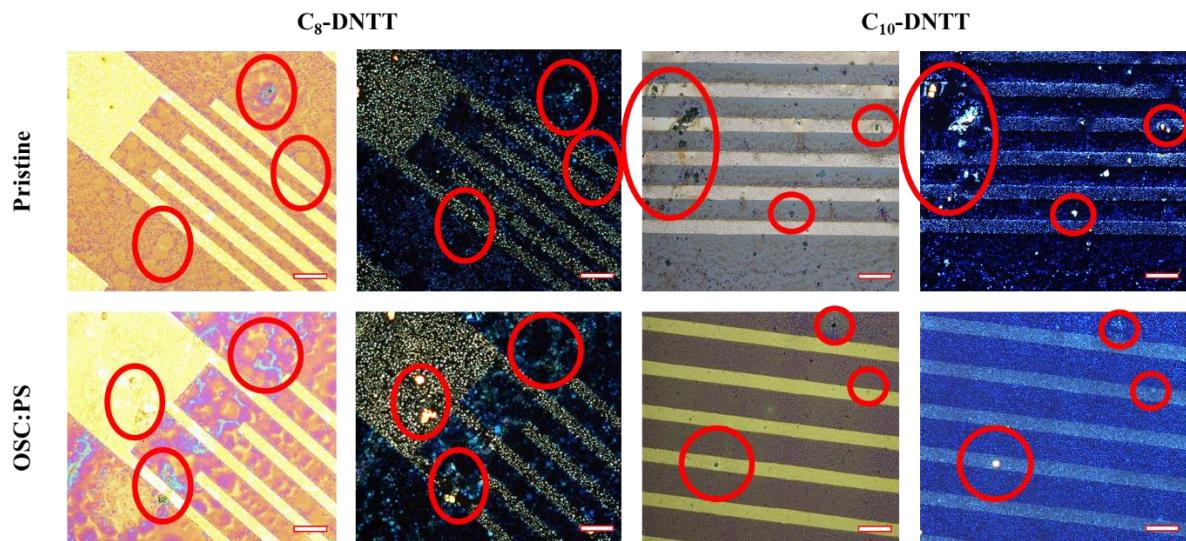


Figure S2. Non-polarised and polarised optical microscopy images of thin films based on C₈-DNTT, C₁₀-DNTT, C₈-DNTT:PS and C₁₀-DNTT:PS deposited by BAMS at 10 mm/s on SiO₂/Si substrates at 105°C. Scale bar: 100 μm. Defects in the films or precipitated crystals are observed (highlighted with a red circle).

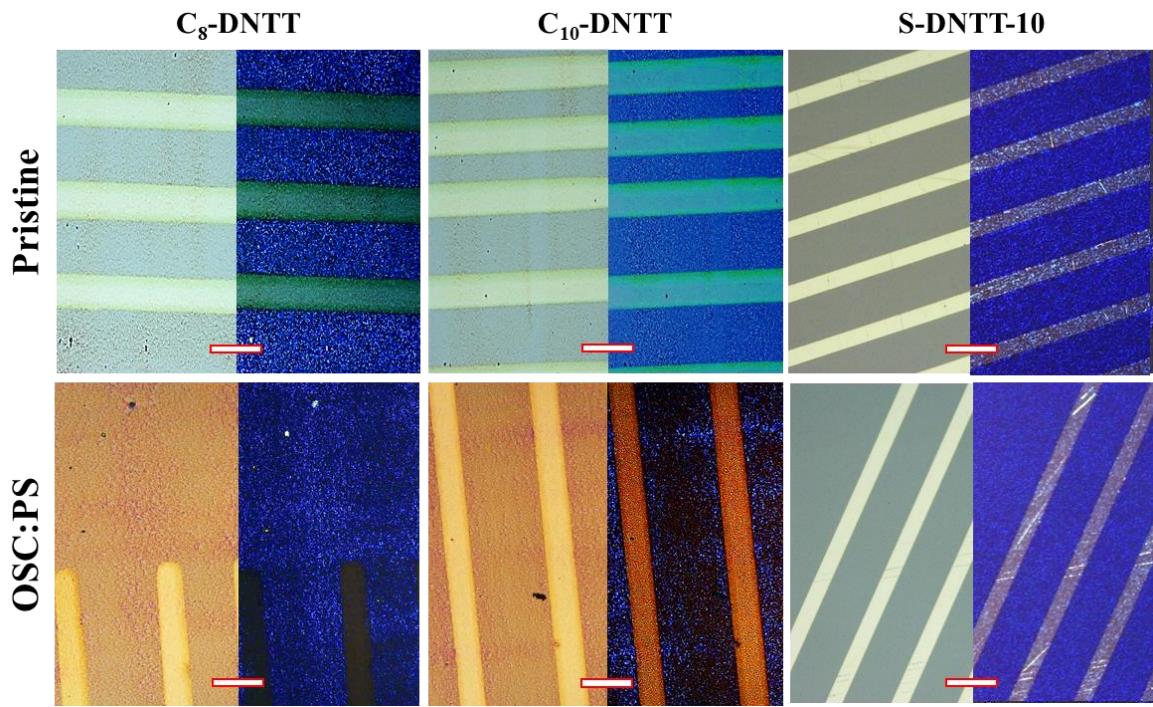


Figure S3. Non polarised and polarised optical microscopy images of the films based on OSC and OSC:PS films deposited by BAMS at 10 mm/s on SiO₂/Si substrates, at 105°C in the case of S-DNTT-10, and at 120°C for the C_n-DNTT derivatives. Scale bar: 100 μm.

Table S1. X-ray crystal data for C₈-DNTT, C₁₀-DNTT and S-DNTT-10 OSCs.

	C ₈ -DNTT ^a	C ₁₀ -DNTT ^b	S-DNTT-10 ^c
Chemical formula	C38H44S2	C42H52S2	C42H52S2
Temperature (K)	293	298	
Cell Lengths (Å)	a = 5.9874 b = 7.8611 c = 34.0658	a = 6.0867 b = 8.0301 c = 37.9349	a = 7.76 b = 7.08 c = 32.30
Cell Angles (°)	α = 90 β = 99.860 γ = 90	α = 90.897 β = 86.298 γ = 90.131	α = 92.20 β = 90.00 γ = 90.00
Cell Volume (Å³)	1579.71	1850.04	
z	2	2	

^aExtracted from the crystal structure reported in reference ¹^bExtracted from the crystal structure reported in reference ²^cExtracted from reference ³**Table S2.** Structural parameters of the thin films based on C₈-DNTT, C₁₀-DNTT and S-DNTT-10 deposited by BAMS technique and estimation of the molecular inclination angle with respect to the substrate normal (Θ_{titl}). ^aMolecular length with extended alkyl chains, estimated from the crystal structure.^{1,2} ^bMolecular length of the S-DNTT-10 extracted from ref 3.

	d ⁰⁰¹ (Å)	L (Å)	Θ _{titl} (°)
C ₈ -DNTT	33.4	34.1 ^a	11
C ₁₀ -DNTT	37.4	38.9 ^a	16
S-DNTT-10	31.5	38.7 ^b	35

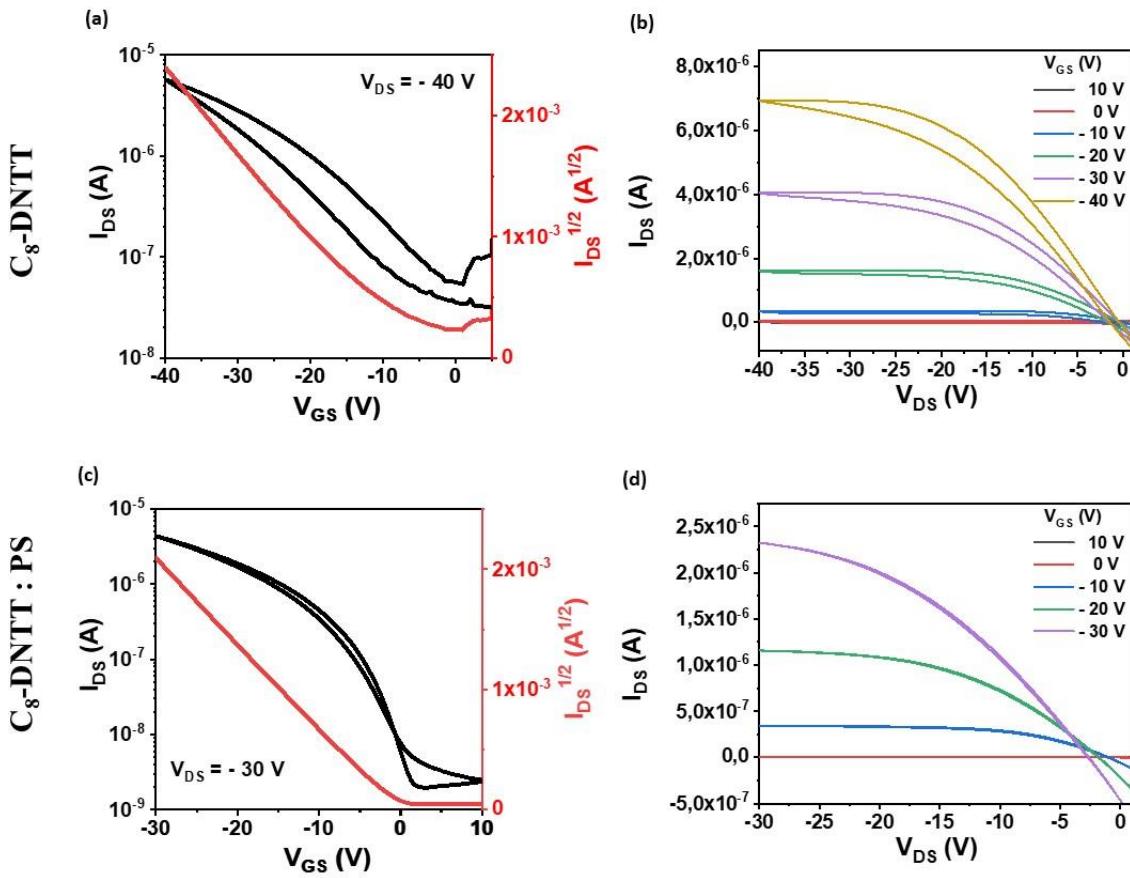


Figure S4. Transfer characteristics in the saturation regime (a,c) and output characteristics (b,d) of OFETs based on $C_8\text{-DNTT}$ and $C_8\text{-DNTT:PS}$ films.

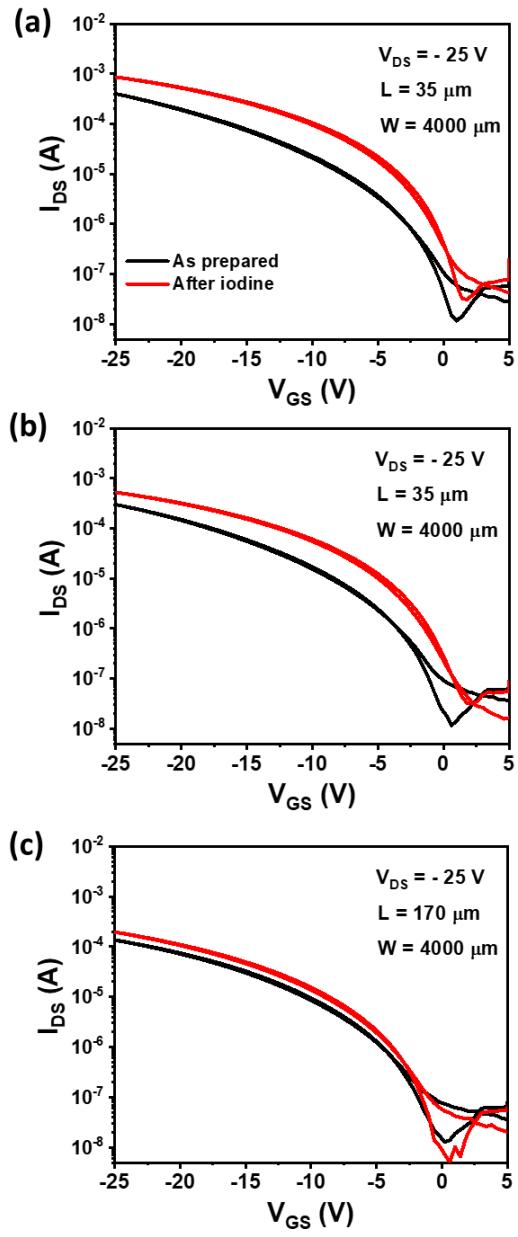


Figure S5. Representative transfer characteristic curves of OFETs based on S-DNTT-10:PS before (black) and after (red) iodine water solution exposition. OFET devices with channel length of (a) 35, (b) 80 and (c) 170 μm .

References

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- 2 F. Talnack, S. Hutsch, M. Bretschneider, Y. Krupskaya, B. Büchner, M. Malfois, M. Hambach, F. Ortmann and S. C. B. Mannsfeld, *Mol. Syst. Des. Eng.*, 2022, **7**, 507–519.
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